CLAIMS:

1. An improved actuation system for positioning a slider carrying a transducing head, the actuation system of the type having a movable actuator arm, a head suspension, a microactuator, a flexure, a slider and a transducing head carried by the slider, the improvement comprising:

an encapsulant comprised of a self assembled monolayer covers exposed surfaces of a component selected from the group consisting of the microactuator, the slider, a disc spacer, surface mount components on a printed circuit card assembly, and ceramic components of the actuation system.

- 2. The improvement of claim 1 wherein the self assembled monolayer is composed of an organosilane.
- 3. The improvement of claim 2 wherein the organosilane is selected from the group consisting of octadecyltrichlorosilane (OTS), octadecyldimethylchlorosilane, butyltrichlorosilane, perfluorodecyltrichlorosilane, alkylsiloxane, alkyl and perfluoroalkyl-trichlorosilane, dichlorosilane, alkene and alkyl ethoxy silanes, octadecyltriethoxysilane, alkylaminosilanes, and alkanethiols.
- 4. The improvement of claim 1 wherein the self assembled monolayer is composed of N-octadecene.
- 5. The improvement of claim 1 wherein the encapsulant has a thickness in the range of about 10 angstroms to about 40 angstroms.
- 6. The improvement of claim 1 wherein the encapsulant selectively adheres to exposed ceramic surfaces of the component.

- 7. A slider comprising:
 - a slider body having a leading edge and a trailing edge;
 - a transducing head positioned proximate the trailing edge of the slider body; and

an encapsulant comprised of a self assembled monolayer covering exposed surfaces the slider body.

- 8. The slider of claim 7 wherein the self assembled monolayer is composed of an organosilane.
- 9. The slider of claim 8 wherein the organosilane is selected from the group consisting of octadecyltrichlorosilane (OTS), octadecyldimethylchlorosilane, butyltrichlorosilane, perfluorodecyltrichlorosilane, alkylsiloxane, alkyl and perfluoroalkyl-trichlorosilane, dichlorosilane, alkene and alkyl ethoxy silanes, octadecyltriethoxysilane, alkylaminosilanes, and alkanethiols.
- 10. The slider of claim 7 wherein the self assembled monolayer is composed of N-octadecene.
- 11. The slider of claim 7 wherein the encapsulant has a thickness in the range of about 10 angstroms to about 40 angstroms.
- 12. The slider of claim 7 wherein the encapsulant is substantially uniform.
- 13. The slider of claim 7 wherein the encapsulant selectively adheres to ceramic surfaces of the slider body.

- 14. The slider of claim 7 wherein the thin organic film is applied to the slider by dip coating, gravity coating, spray coating, screen coating, roll coating or vapor phase deposition.
- 15. A microactuator comprising:

 a first piezoelectric element attached between a mounting block and
 a suspension, the first piezoelectric element being
 deformable in response to a voltage applied thereto;
 an encapsulant comprised of a self assembled monolayer covering
 exposed surfaces of the first piezoelectric element; and
 a compliant joint between the mounting block and the suspension,
 the compliant joint being flexible to permit movement of the
 suspension with respect to the mounting block.
- 16. The microactuator of claim 15 wherein the self assembled monolayer is composed of an organosilane.
- 17. The microactuator of claim 16 wherein the organosilane is selected from the group consisting of octadecyltrichlorosilane (OTS), octadecyldimethylchlorosilane, butyltrichlorosilane, perfluorodecyltrichlorosilane, alkylsiloxane, alkyl and perfluoroalkyl-trichlorosilane, dichlorosilane, alkene and alkyl ethoxy silanes, octadecyltriethoxysilane, alkylaminosilanes, and alkanethiols.
- 18. The microactuator of claim 15 wherein the self assembled monolayer is composed of N-octadecene.
- 19. The microactuator of claim 15 wherein the encapsulant has a thickness between about 10 angstroms and about 40 angstroms.

- 20. The microactuator of claim 15 wherein the encapsulant selectively adheres to exposed ceramic materials of the first piezoelectric element.
- 21. The microactuator of claim 15, and further comprising a second piezoelectric element attached between the mounting block and the suspension, the second piezoelectric element being covered by an encapsulant comprised of a self assembled monolayer and deformable in a direction complementary to deformation of the first piezoelectric element in response to a voltage applied thereto.